

RECEIVED
CENTRAL FAX CENTER

003/007

MAY 25 2005

PATENT

Atty. Dkt. No. AMAT/5750/CPIL/B/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Miyanaga, et al.

Serial No.: 10/045,745

Confirmation No.: 9682

Filed: October 26, 2001

For: Cleaning Method for Vapor
Phase Deposition
Apparatus, and Vapor
Phase Deposition
Apparatus

Group Art Unit: 1746

Examiner: Andrew McAleavey

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8I hereby certify that this correspondence and the documents
referred to as attached therein are being facsimile transmitted
to the U.S. Patent and Trademark Office to the fax number
indicated by the Examiner, namely, fax number (703) 872-
9306 to the attention of the named Examiner, on the date
below.

5/25/05

Date

Signature

Dear Sir:

RESPONSE TO FINAL OFFICE ACTION DATED MARCH 25, 2005

In response to the Final Office Action dated March 25, 2005, having a shortened statutory period for response set to expire on June 25, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5750/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

The Pending Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 4 of this paper.

Page 1

359932_1